Ar ation No.: 08/799,506 Group: 2822

Page 2

In the claims:

Please amend claims 80, 82, 85, 88, 91, 94, 97, 100 and 103 as follows:

80. (Amended) A multi-chamber system comprising:

a first chamber for irradiating laser light to a semiconductor film formed over a substrate;

a second chamber for depositing a gate insulating film on said semiconductor film; and

[A] a third chamber capable of taking said substrate out of said multi-chamber system after depositing said gate insulating film.

82. (Amended) A multi-chamber system according to claim 81 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

85. (Amended) A multi-chamber system according to claim 84 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

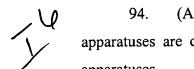
88. (Amended) A multi-chamber system according to claim 87 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

91. (Amended) multi-chamber system according to claim 90 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

ation No.: 08/799,506

Group: 2822

Page 3



A multi-shamber system according to claim 93 wherein [said (Amended) fillion oxide film is formed by one of said apparatuses are capable of forming apparatuses.

97. A multi-chamber system according to claim 96 wherein [said (Amended) apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

A multi-clamber system according to claim 99 wherein [said 100. (Amended) Vicon oxide film is formed by one of said apparatuses are capable of forming apparatuses.

(Amended) \ \ \ A multi-chamber system according to claim 102 wherein 103. [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

Please add new claims 104-123 as follows:

√104. (New) A multi-chamber system according to claim 80 wherein said

laser light comprises an excimer laser light.

 $\sqrt{105}$. A multi-chambel system according to claim 80 wherein said (New) laser light has a linear shape.

√ 106. (New) A multi-chamber system according to claim 83 wherein said

laser light comprises an excimer laser light.

Ap ation No.: 08/799,506

Group: 2822

Page 4

107. (New) A multi-chamber system according to claim 83 wherein said laser light has a linear shape.

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v 108. (New) A multi-chamber system according to claim 86 wherein said laser light comprises an excimer laser light.

109. (New) A multi-chamber system according to claim 86 wherein said laser light has a linear shape.

110. (New) A multi-chamber system according to claim 86 wherein said means for transporting said substrate comprises a robot hand.

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√111. (New) A multi-chamber system according to elaim 89 wherein said laser light comprises an excimer laser light.

112. (New) A multi-chamber system according to claim 89 wherein said laser light has a linear shape.

113. (New) Amulti-chamber system according to claim 89 wherein said means for transporting said substrate comprises a robot hand.

114. (New) A multi-chamber system according to claim 92 wherein said laser light comprises an excimer laser light.

115. (New) A multi-chamber system according to claim 92 wherein said

pation No.: 08/799,506

Group: 2822

Page 5

laser light has a lineal shape.

A multi-chamber system according to claim 95 wherein said laser light comprises an excimer laser light.

 $\sqrt{117}$. A multi-chamber system according to claim 95 wherein said (New) laser light has a linear shape.

A multi-chamber system according to claim 98 wherein said (New) laser light comprises an excimer laser light.

√ 119. A multi-chamber system according to claim 98 wherein said laser light has a linear shape.

A make chamber system according to claim 98 wherein said 120. (New) means for transporting said substrate comprises a robot hand.

A multi-chamber system according to claim 101 wherein said 121. (New) laser light comprises an excimer laser light.

A multi-chamber system according to claim 101 wherein said 122. (New) laser light has a linear shape.

A multi-chamber system according to claim 101 wherein said 123. (New) means for transporting said substrate comprises a robot hand.